

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No.: 3788
Shinji MAEKAWA et al.	)	
Application No. 10/575,492	)	Examiner: Stanetta D. Isaac
Filed: April 12, 2006	)	Group Art Unit: 2812
For: METHOD FOR FORMING WIRING, METHOD	)	
FOR MANUFACTURING THIN FILM	)	
TRANSISTOR AND DROPLET DISCHARGING	)	
METHOD	)	

**AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed March 10, 2009, please amend the above-captioned application, as follows:

**Amendments to the Claims** are reflected in the listing of claims in the paper.

**Remarks** follow the amendment section of this paper.